



IPW

Docket No.: 57454-947

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Koichiro NARIMATSU : Confirmation Number: 4863
Application No.: 10/603,738 : Group Art Unit: 2814
Filed: June 26, 2003 : Examiner: Pham, Long
For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF, AND
REGISTRATION ACCURACY MEASUREMENT ENHANCEMENT METHOD

REQUEST FOR RECONSIDERATION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Remarks are submitted in response to the Office Action dated October 15,
2004.